SEP 21 7004

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plicant(s): Ronald A. Weimer, et al.  ention: FABRICATION OF DRAM AND OTHER SEMICONDUCTOR DEVICES WITH AN INSULATING FILM USING A WET RAPID THERMAL OXIDATION PROCESS  TO THE COMMISSIONER FOR PATENTS  ransmitted herewith is an amendment in the above-identified application. The fee has been calculated and is transmitted as shown below.  CLAIMS AS AMENDED    Claims   Highest Number Previously Extra Claims Present   Rate	••				ETTER	M4065.0319/P	
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Multiple Dependent Claims (check if applicable)  Other fee (please specify):  TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:  x Large Entity  x No additional fee is required for this amendment.  Please charge Deposit Account No in the amount of \$ A duplicate copy of this sheet is enclosed.  A check in the amount of \$ to cover the filing fee is enclosed.  Payment by credit card. Form PTO-2038 is attached.  x The Commissioner is hereby authorized to charge and credit Deposit Account No 04 as described below. A duplicate copy of this sheet is enclosed.  x Credit any overpayment.  x Charge any additional filing or application processing fees required under 37 CFR 1.16 and Dated: Dated: Dated: Dated:	aims	5	- 40 =		×	0.0	0
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Thomas J. D'Amico	Ja	<u> </u>			Dated: S	eptember 21, 20	04
Attorney Reg. No.: 28,371 DICKSTEIN SHAPIRO MORIN & OSHINSKY LLP		<u>-</u>	N & OSHINSK	Y LLP			
2101 L Street NW Washington, DC 20037-1526		20037-1526					
(202) 828-2232	•						
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Docket No.: M4065.0319/P319-A

(PATENT)

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Ronald A. Weimer, et al.

Confirmation No.: 5990

Application No.: 09/912,558

Art Unit: 2813

Filed: July 26, 2001

Examiner: E. J. Kielin

For: FABRICATION OF DRAM AND OTHER

SEMICONDUCTOR DEVICES WITH AN INSULATING FILM USING A WET RAPID

THERMAL OXIDATION PROCESS

## **AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)**

Commissioner for Patents

MS: AF

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

This paper is in response to the Office Action dated July 20, 2004. Please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.